



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of: SINGH et al.

Application No.: 10/082,010

Examiner: Umez Eronini, Lynette T.


Date Filed: February 22, 2002

Group: 1765

For: SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING
OF METAL STRUCTURES INCLUDING REFRACTORY METAL
BASED BARRIER LAYERS

CERTIFICATE UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class mail in an envelope addressed to the Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 3, 2004.

 Reg. No. 40,764
Mark D. Passler

REPLY TO FINAL OFFICE ACTION

Mail Stop RCE
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated June 3, 2004, a Reply is presented as follows:

A complete **Claim** listing appears on pages 2-10.

Remarks/Arguments begin on page 11 of this paper.